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## \*\* CONTINUING DATA \*\*\*\*\*

This application is a DIV of 09/651,255 08/30/2000 PAT 6,491,758 *verified. ep*

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN 11-246240 08/31/1999

JAPAN P2000-052555 02/28/2000 *verified.*JAPAN P2000-052516 02/28/2000 *ep*

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

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Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR	SHEETS	TOTAL	INDEPENDE
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	COUNTRY	DRAWING	CLAIMS	CLAIMS
Verified and Acknowledged Examiner's Signature <i>[Signature]</i> Initials <i>sf</i>	JAPAN	9	6	3

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## TITLE

Method of purging CVD apparatus and method for judging maintenance of times of semiconductor production apparatuses

FILING FEE	FEES: Authority has been given in Paper	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing )
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